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CONFIRMATION NO. 8920

Bib Data Sheet

SERIAL NUMBER 10/800,112	FILING OR 371(c) DATE 03/12/2004 RULE	CLASS 216	GROUP ART UNIT 1765	ATTORNEY DOCKET NO. 008245/DSM/BCVD
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** CONTINUING DATA *****

** FOREIGN APPLICATIONS *****

IF REQUIRED, FOREIGN FILING LICENSE GRANTED

** 07/31/2004

Foreign Priority claimed	<input type="checkbox"/> yes <input checked="" type="checkbox"/> no	STATE OR COUNTRY	SHEETS DRAWING	TOTAL CLAIMS	INDEPENDENT CLAIMS
35 USC 119 (a-d) conditions met	<input type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> Met after Allowance	CA	1	22	3
Verified and Acknowledged	Examiner's Signature Initials				

ADDRESS

44257

TITLE

Method of depositing an amorphous carbon film for metal etch hardmask application

FILING FEE RECEIVED 936	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following:	<input type="checkbox"/> All Fees <input type="checkbox"/> 1.16 Fees (Filing) <input type="checkbox"/> 1.17 Fees (Processing Ext. of time) <input type="checkbox"/> 1.18 Fees (Issue) <input type="checkbox"/> Other <input type="checkbox"/> Credit
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